

Form PTO-1449

Doc No (Number) (Specimen)

Applicant's Name

TSMC-03-627

10/807,081

Applicant

Hung-Wei Chen et al.

Filing Date

03/23/04

Drawn At Unit

01 INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION.

MAY 06 2004

(so several sheets if necessary)

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	ALSO DATE APPROPRIATE
AKS	5468657	11/21/95	Hsu	437	24	6/17/94
	6613678	9/24/03	Sakaguchi et al.	438	695	5/17/99
	6410938	6/25/02	Xiang	257	49	4/3/01
	5656537	8/12/97	Iwamatsu et al.	438	402	6/5/95
AKS	5910672	6/8/99	Iwamatsu et al.	257	347	7/7/97

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

Asdu Umar Sarker

9/20/25

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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